



Dear Educators:

We are elated to extend to you an invitation to join us at our 2017 STEAM+ Professional Development Program in Washington, DC. The program will run from **Friday-Sunday, July 28-30.**

We are thrilled to welcome quite an incredible lineup of guest speakers and authors, who are anxious to pour their knowledge into us during this rewarding event.

Over 100 participants, including educators, art advocates, artists and policy shapers, will attend our 2017 STEAM+ Professional Development Program. Join us as we enjoy diving deeper into the topic of incorporating art themes into our interdisciplinary education. Come see how we are taking Science, Technology, Engineering and Math to the next level by incorporating multi-subject, multidisciplinary ideas.

Attendees will also enjoy visits to collections at the National Museum of Women in the Arts, meet and greet sessions with some of our guest speakers and authors and visits to other institutions and cultural sites, such as the Smithsonian National Museum of African American History & Culture.

This year, we are proud to have collaborated with so many global partners, including: The US Department of Education, Paul S. Devroux, Jr. Memorial Lecture (PSDML), National Museum of Women in the Arts, Smithsonian National Museum of African American History & Culture, Community MicroEnterprise Center, Wells International Foundation, Washington, DC Convention Center and the Organization of Black Designers.

Now is the time to register for this exciting event! With summer coming up, you want to ensure that you have this program already down in your calendar. We encourage you to also inquire at your school and see if they sponsor professional development events.

If you would like to accept our invitation to join, please register [online](#). To learn more about the program and view the agenda, please visit our website, jrevesteam.com.

We look forward to seeing you in Washington, DC!

With excitement,

Jacqueline Cofield
Founder, J Rêve International